

## BEST AVAILABLE COPY

### PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SAKAI et al.

Group Art Unit: 2812

Application No.: 10/714,644

Examiner:

Toly

Filed: November 18, 2003

Docket No.: 117787

For:

METHOD FOR FABRICATING A SIGE FILM, SUBSTRATE FOR EPITAXIAL

GROWTH AND MULTILAYERED STRUCTURE

### INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir.

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- X This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection, Notice of Allowance or other action that closes prosecution (e.g., Quayle Action).
  - Ø I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(c)(1).
- Ø 2. The references were cited in a counterpart foreign application.
- Ø 3. English language Abstracts of the non-English language references are attached hereto.

**BEST AVAILABLE COPY** 

DEPLRET

# BEST AVAILABLE COPY

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 16 THE TEST

In re the Application of

ATTN:

Refund Section FADE ANK

Accounting Dive Office of Finance

Akira SAKAI et al.

Application No.: 10/714,644

Docket No.: 117787

Filed: November 18, 2003

For:

METHOD FOR FABRICATING A SIGE FILM, SUBSTRATE FOR EPITAXIAL

GROWTH AND MULTILAYERED STRUCTURE

## REQUEST FOR REFUND TO DEPOSIT ACCOUNT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Attached hereto is a copy of a Monthly Statement of Deposit Account (dated June Sir: 28, 2005) showing a charge of \$180.00 related to the above-referenced application. This charge is marked with Fee Code 1806, which is the Patent Office Fee for an Information Disclosure Statement. However, the Information Disclosure Statement was filed on June 16, 2005, which is the day the Final Rejection was issued. As both documents were dated the same day, the order of action is unclear. In keeping with other actions where Applicants and the Patent Office act on the same day, the filing of the Information Disclosure Statement should be treated as before the mailing of the Final Office Action. Therefore, Applicants respectfully submit that the Information Disclosure Statement was timely filed.

### **BEST AVAILABLE COPY**

Account No. 15-0461 and that the Patent Office acknowledge this credit in writing.

Respectfully

Registration No. 27,075

Dahart A Miller

Robert A. Miller Registration No. 32,771

JAO:RAM/tls

Date: August 15, 2005

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

## **BEST AVAILABLE COPY**

## **Deposit Account Statement**

Requested Statement Month:

Deposit Account Number:

150461

June 2005

Name:

OLIFF & BERRIDGE P L C

Attention:

BARBARA WATTS

Address:

277 SOUTH WASHINGTON STREET

City:

ALEXANDRIA

State:

VA

Zip:

22314

Country:

UNITED STATES OF AMERICA

ATTORNEY **POSTING** 

FEE

SEQ

1

**REF TXT** 

DOCKET

CODE

**AMT** 

06/28

DATE

10714644

**NBR** 117787

1806

\$180.00